Low-Loss Waveguides Fabricated by Femtosecond Chirped-Pulse Oscillator

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Outline

Principle of femtosecond microfabrication

Historic prospective

Motivation for the present work

Fs inscription of waveguides

Waveguide characterisation

Bending losses

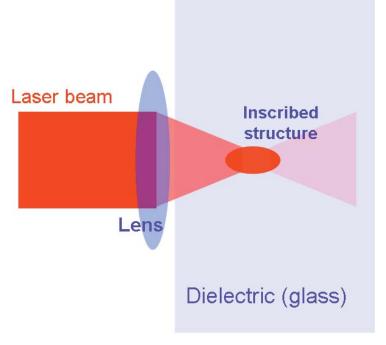
Conclusions



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Principle of femtosecond (fs) microfabrication

femtosecond microfabrication for dummies



Laser pulse enters left to right



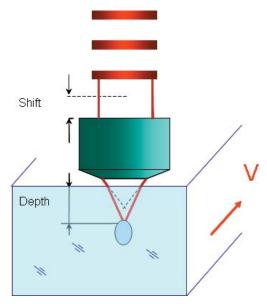
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Femtosecond micro-fabrication/machining

Experimental implementation



Schematic of fs inscription



Experimental setup



First demonstration of fs microfabrication

[Davis et al Opt. Lett. 1996]

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Writing waveguides in glass with a femtosecond laser

K. M. Davis, K. Miura, N. Sugimoto, and K. Hirao

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Received May 6, 1996

With the goal of being able to create optical devices for the telecommunications industry, we investigated the effects of 810-nm, femtosecond laser radiation on various glasses. By focusing the laser beam through a microscope objective, we successfully wrote transparent, but visible, round-elliptical damage lines inside high-silica, borate, soda lime silicate, and fluorozirconate (ZBLAN) bulk glasses. Microellipsometer measurements of the damaged region in the pure and Ge-doped silica glasses showed a 0.01-0.035 refractive-index increase, depending on the radiation dose. The formation of several defects, including Si E' or Ge E' centers, nonbridging oxygen hole centers, and peroxy radicals, was also detected. These results suggest that multiphoton interactions occur in the glasses and that it may be possible to write three-dimensional optical circuits in bulk glasses with such a focused laser beam technique. © 1996 Optical Society of America

Since the 1970's, many investigations of the effects of UV radiation damage in high-silica glasses (especially Ge-doped silica glass) have been performed with the objective of producing optical devices (e.g., Bragg gratings) in fibers and thin films. In contrast, laser

square-wave pulse, a uniform beam intensity, and a diameter of the laser focal point that is equal to the thickness of the observed damage lines ($\sim 6~\mu$ m), we found that the samples experienced 12,000 pulses/spot, and each spot was subjected to a dose of



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First demonstration of fs microfabrication

[Davis et al Opt. Lett. 1996]

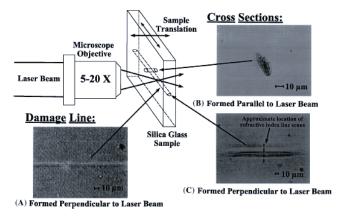


Fig. 1. Laser damage process with images of (A) a laser damage line, (B) the cross section of a line written by translation of the sample parallel to the incident laser beam, and (C) the cross section of a line written by translation of the sample perpendicular to the incident laser beam by a 5× microscope objective. The dashed line in (C) represents the path traversed during the microellipsometer measurements.



Femtosecond micro-fabrication/machining

3D examples



Fig. 1. (a) Schematic of the symmetric three-waveguide directional coupler. Waveguides are initially separated by 50 μ m and by 5 μ m in interaction region L. (b) Inverse gray-scale CCD image of the waveguide outputs shows a 43:28:29 power-splitting ratio between the guides.

Microfabrication of 3D couplers. Kowalevitz et al, 2005

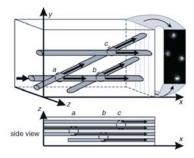


Fig. 3 Schematic of 1×4 splitter (top and side view) with experimental near-field of output face at 1550 nm

3D splitter. Osellame et al, 2005

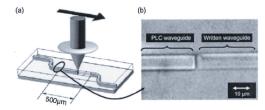


Fig. 5. (a) Schematic diagram of the waveguide connection in this experiment. (b) Image at the junction point of waveguide connection.

Lightwave Circuits. Nasu et al, 2005

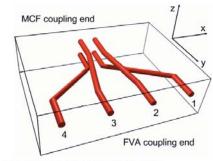


Fig. 1. Graphical representation of the fabricated fan-out device.

Fan out coupler. Thomson et al, 2007



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Motivation for the present work

- ► Find key parameters to achieve well performing curved waveguides in bulk materials
- ► Produce reliable optimised 2D/2.5D/3D structures ready for applications in integrated optics
- ▶ Demonstrate Bragg gratings embedded into waveguides in a single process of wavegiuide inscription.



Choice of a chisel

Parameter	1 kHz, 800 mJ 110 fs	11 MHz, 100 nJ 45-55 fs	Enh.
Efficiency (Utilization) of Laser Energy	80-800 nJ (10^{-4})	20-60 nJ (0.2-0.6)	$> 10^3$
Index Contrast, Δn	$> 10^{-3}$	$> 10^{-2}$	10
Translation speed, mm/s	0.01-0.1	10–100	$> 10^3$
WG diameter,mm	< 2	< 20	10



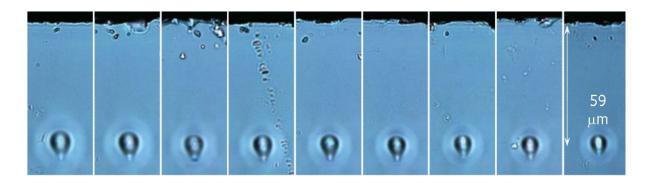
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Waveguide inscription

Shown: microphotographs of the waveguide cross-sections for translation speeds 20 to 60 mm/s increasing left to right



All waveguides shown above were inscribed with pulse energy of 30.7 nJ. Focal point was shifted inwards by about 45 μ m (actual depth is about 59 μ m).



Waveguide inscription

Optimisation parameter space

Optimisation Target: lowest possible total losses of waveguide

Pulse Energy, nJ	x5	17, 19.2,, 31
Translation speed: mm/s	×9	20, 25,, 55, 60
Inscription depth, mm	x3	68 , 83 and 100
Polarizations:	x2(3)	$X - \bot$ and $Y - \ $
		to scan direction)
Translation direction	×2	Forward and Backward

Total: 540 tracks

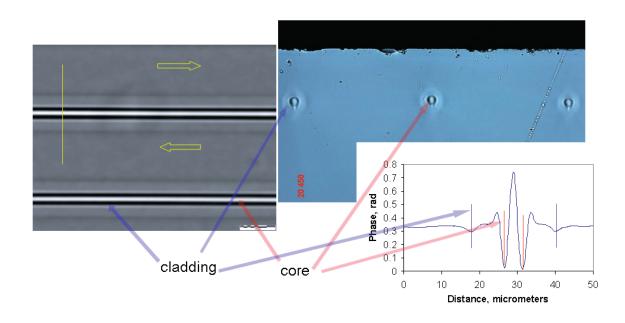


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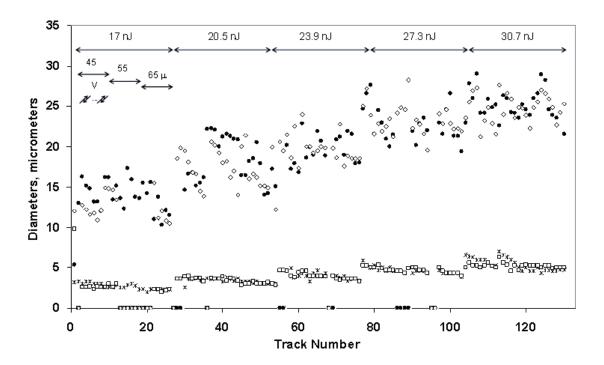
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Morphology of smooth well performing waveguides



Waveguide diameters



Core and cladding diameters for X (\diamond – cladding, \Box – core) and Y-polarizations (\bullet – cladding, *– core).

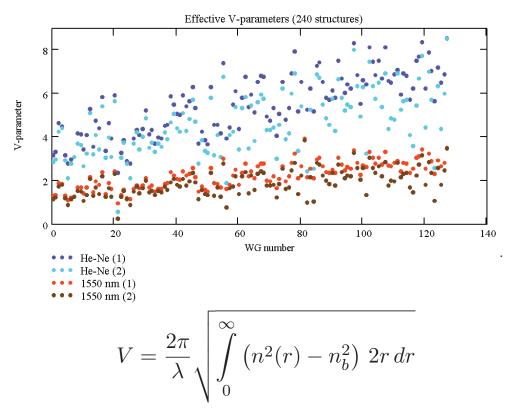


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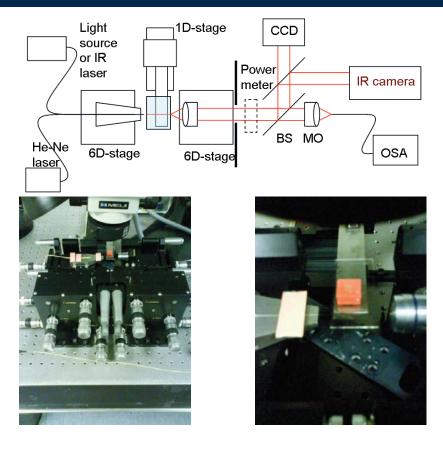
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V-parameter for gradient index waveguides





A rig for waveguide characterisation





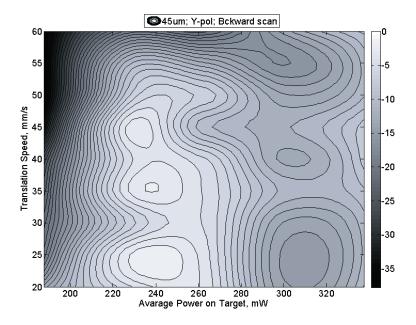
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Waveguide lossses

Treasure map

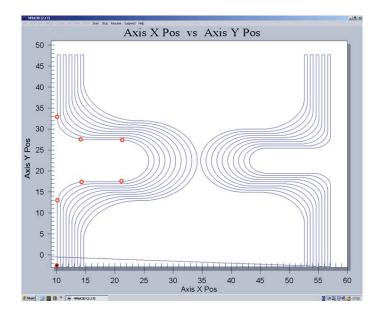


Optimal regime is an island in energy – translation speed plane. Propagation losses of optimal waveguides are found to be about

0.1 dB/cm @633 nm and 0.5 dB/cm @1550 nm

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Bending losses. Tracks



Optimal inscription regimes were exploited to manufacture **curved** tracks. All the tracks are designed to have the same length and comprise straight stretches and 4 arcs with different directions and curvatures

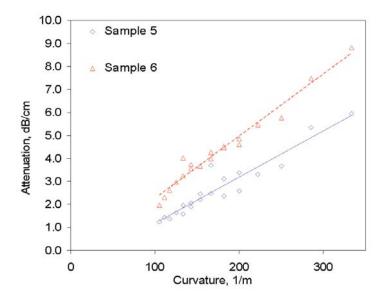
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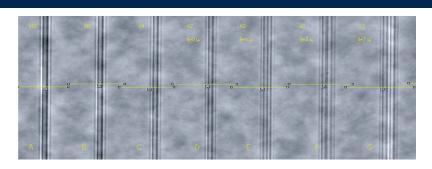
Bending losses. Measurements

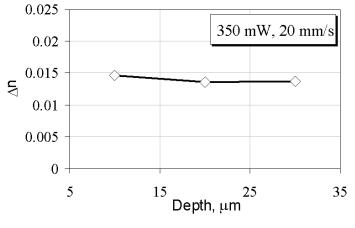


Bending losses of optimal curved tracks compare to those of fibres and are now suitable for applications in integral optics.



Shallow and multiscan waveguides







Ref. index vs depth

Image of near field mode

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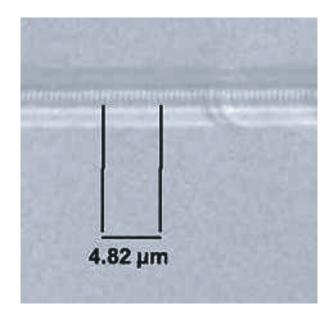
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FBG structure embedded in fs inscribed waveguide

Work in progress.



Pulse power of the beam is modulated to induce a visually perfect periodic structure.

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Conclusions

- ► Operation regimes for microfabrication of waveguides suitable for application optics found.
- ► Curvilinear waveguides with acceptable bending losses are demonstrated.
- ► FBG structure embedded in the waveguide fabricated in a single process with fabrication of the waveguide.



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